Matter No.: 10559-881001 Applicant(s): Yan Borodovsky

COMPOSITE OPTICAL LITHOGRAPHY METHOD FOR PATTERNING LINES OF SUBSTANTIALLY EQUAL WIDTH

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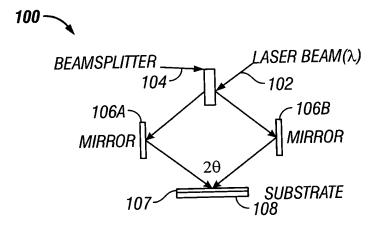


FIG. 1A

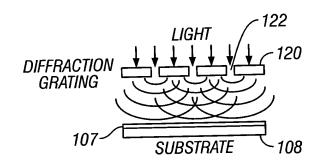


FIG. 1B

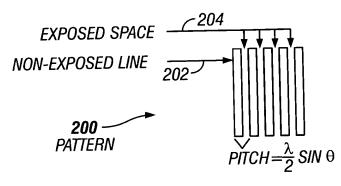


FIG. 2

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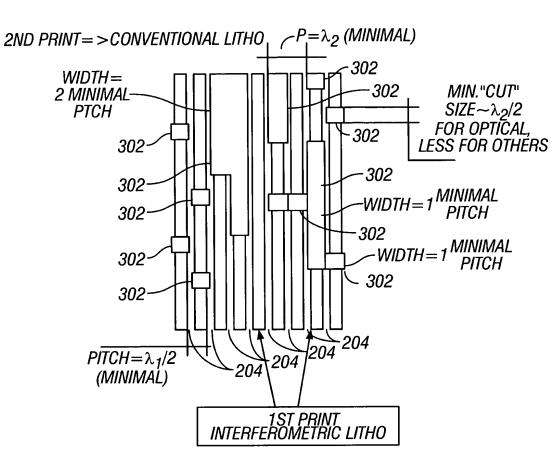


FIG. 3A

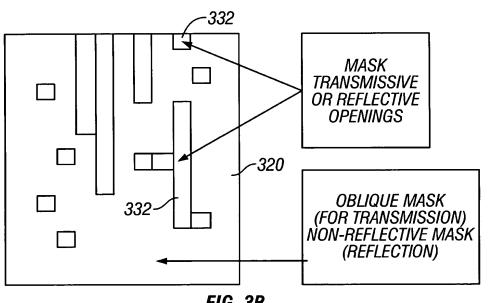
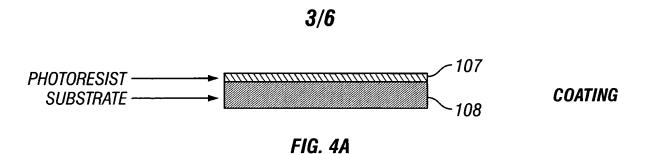
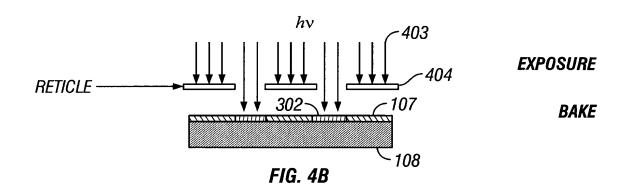


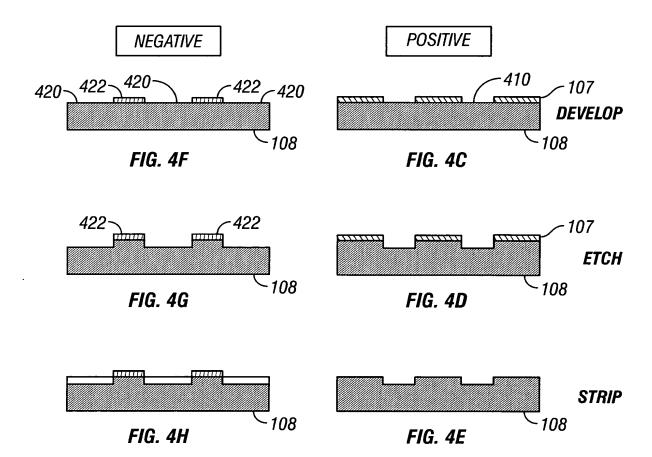
FIG. 3B

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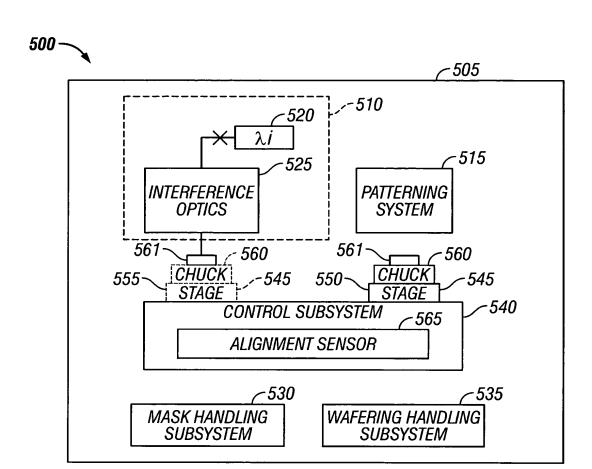


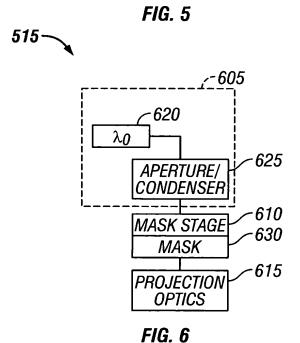




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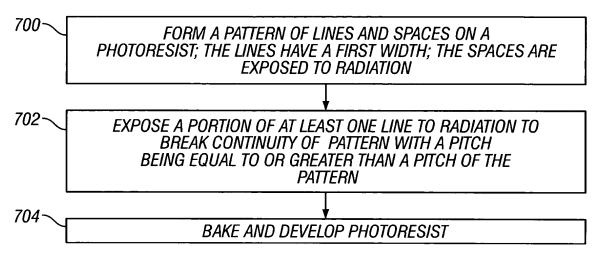


FIG. 7

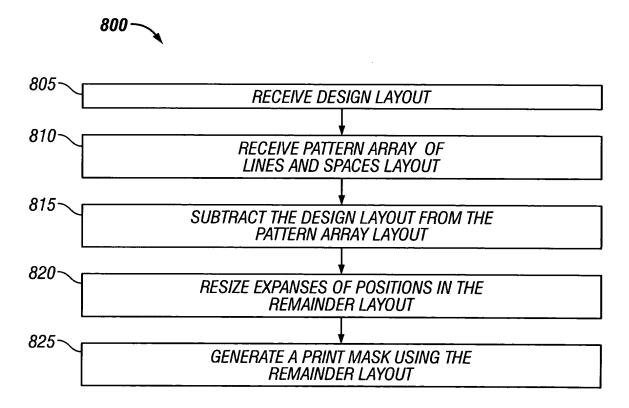


FIG. 8

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